

Application No.: 09/580,485  
Art Unit: 2813

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### REMARKS

The Examiner's Notice of Allowability mailed September 19, 2002 has been received and its contents carefully noted. The above amendments are presented in response thereto in order to correct a typographical error which occurred when presenting claim 1 in the AMENDMENT AFTER FINAL of May 31, 2002. The typographical error was the omission of two proper sets of brackets, i.e., " [ ]," at the end of claim 1. Currently, the last two lines of claim 1 reads as follows:

"wherein the EL layer is selectively formed through an ink jet method,

wherein the insulating film is capable of preventing penetration of alkaline metal]"

However, a review of the entire AMENDMENT AFTER FINAL of May 31, 2002, particularly the amendments to each of the other independent claims 2-5 (see pages 18-20 of the AMENDMENT AFTER FINAL), reveals that the Applicants intended for independent claims 1 to 5 to be amended to conclude with the phrase:

"wherein the EL layer is selectively formed through an ink jet method."

The Applicants' intention to limit claims 1-5 in this manner is further reinforced by the Applicants' discussion of the invention in the AMENDMENT AFTER FINAL, at pages 12 and 13, where the importance of forming the EL layer through an ink jet method is stressed. Clearly, the omission of the necessary number of brackets in claim 1, in the AMENDMENT AFTER FINAL, was an inadvertent and obvious typographical error, particularly since the claim 1 in its current form contains, at the end of the last line, an extraneous " ] " closing bracket.

Due to the clear typographical nature of the error in presenting claim 1 in the AMENDMENT AFTER FINAL, it is believed no further search and examination is required by the current amendment to claim 1, and consideration and entry of the proposed amendment is earnestly solicited.

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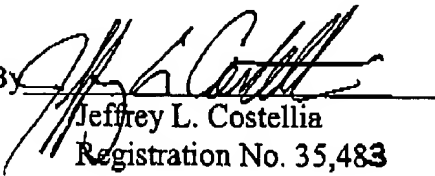
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VERSION OF AMENDED CLAIM WITH  
MARKINGS TO SHOW CHANGES MADE

IN THE CLAIMS:

Please amend claim 1 as follows.

1. (Thrice Amended) A method for manufacturing an electrical device, said method comprising:

forming at least a thin film transistor on an insulating surface;

forming a first insulating film comprising an organic resin over the thin film transistor;

forming a second insulating film comprising silicon nitride on the first insulating film;

forming a pixel electrode on the second insulating film, said pixel electrode electrically connected to the thin film transistor;

forming an EL layer over the pixel electrode;

forming a second electrode over the EL layer,

wherein the EL layer is selectively formed through an ink jet method[,

wherein the insulating film is capable of preventing penetration of alkaline metal]].